

Title	表紙
Sub Title	
Author	
Publisher	慶應義塾大学理工学部
Publication year	1994
Jtitle	Keio Science and Technology Reports Vol.47, No.1 (1995. 1)
JaLC DOI	
Abstract	
Notes	表紙裏：編集委員会
Genre	
URL	https://koara.lib.keio.ac.jp/xoonips/modules/xoonips/detail.php?koara_id=KO50001004-00470001--001

慶應義塾大学学術情報リポジトリ(KOARA)に掲載されているコンテンツの著作権は、それぞれの著作者、学会または出版社/発行者に帰属し、その権利は著作権法によって保護されています。引用にあたっては、著作権法を遵守してご利用ください。

The copyrights of content available on the KeiO Associated Repository of Academic resources (KOARA) belong to the respective authors, academic societies, or publishers/issuers, and these rights are protected by the Japanese Copyright Act. When quoting the content, please follow the Japanese copyright act.

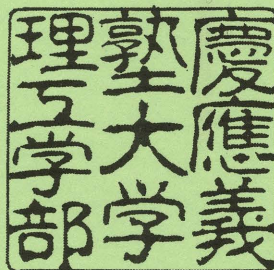
KEIO SCIENCE AND TECHNOLOGY REPORTS

VOL. 47 NO. 1 (1994)

EFFECT OF O^+ ION BEAM ON THE ELECTRICAL
CONDUCTION OF CARBON FILMS
BY IBSD TECHNIQUE

By

YOSHIKO OHASHI and TAKUYA ISE



FACULTY OF SCIENCE AND TECHNOLOGY
KEIO UNIVERSITY

DEAN

Y. Anzai

EDITORIAL BOARD

H. Tanaka *Dept. of Mathematics (Chairman)*

T. Kuno *Dept. of Mechanical Engineering*

N. Hamada *Dept. of Electrical Engineering*

K. Umezawa *Dept. of Applied Chemistry*

J. Muto *Dept. of Instrumentation Engineering*

H. Yanai *Dept. of Administration Engineering*

S. Nosé *Dept. of Physics*

A. Nakajima *Dept. of Chemistry*

I. Honda *Dept. of Mathematics*

Keio Science and Technology Reports (KSTR) is a continuation of Keio Engineering Reports which was formerly Proceedings of the Fujihara Memorial Faculty of Engineering, Keio University. It appears irregularly under the editorship of the Faculty of Science and Technology, Keio University. Inquiries concerning contribution, subscription or exchange should be written to:

The Editorial Office
Faculty of Science and Technology, Keio University
Hiyoshi 3-14-1, Kohoku-ku
Yokohama 223, Japan

PURPOSE AND SCOPE OF KSTR

The purpose of KSTR is to publish original articles written by the members of our Faculty. Contribution from non-member author will be received only if the Editorial Board judges it appropriate. Topics which appear in KSTR will cover the entire fields with which our Faculty is concerned; namely mechanical engineering, electrical engineering, chemistry, chemical technology, instrumentation engineering, administration engineering, pure and applied physics, pure and applied mathematics.

INSTRUCTION TO CONTRIBUTORS

Paper should be written in English, German or French. Manuscript should be typewritten, double-spaced with wide margins. Contributed paper must be original. However the translation into above-mentioned languages of the original article in Japanese which appeared elsewhere will also be accepted if the Editorial Board judges it competent. No page charge is required and 100 copies of offprints will be provided to the author free of charge.

KEIO SCIENCE AND TECHNOLOGY REPORTS Vol. 47, No. 1 January 1995

Published by the Faculty of Science and Technology, Keio University

Kohoku-ku, Yokohama-shi, Kanagawa 223, Japan

Copyright © 1982 by the Faculty of Science and Technology

Keio University